

PATENT
03371-P0005A LHR

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

JC813 U.S. Pro
09/69317 10/28/00
10/28/00

Applicants	Lynn David Bollinger, et al.
Serial No. - Pending	Filing Date: October 20, 2000
Title of Application:	Method for Rapid Thermal Processing of Substrates

Assistant Commissioner for Patents
Washington, DC 20231

Information Disclosure Statement by Applicants

Dear Sir:

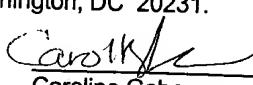
As a means of complying with duty of disclosure set forth in 37 CFR §1.56, Applicants list the following references (copies of the listed patents and papers enclosed):

U.S. Patent Documents

Exam. Initials	Class/ Subclass.	Document No.	Date	Name
MW	_____	5,474,642	12/12/95	Vecleslav, et al.
MW	_____	5,489,820	02/06/96	Vladimir, et al.
MW	_____	5,562,841	10/08/96	Pavel, et al.

Express Mail Certificate: I hereby certify that this correspondence is today being deposited with the U.S. Postal Service as *Express Mail Post Office to Addressee* Mailing Label Number EL 576 896 246 US in an envelope addressed to: Assistant Commissioner for Patents; Washington, DC 20231.

October 20, 2000


Caroline Gahagan

Page 2
Serial No.
Information Disclosure Statement

Foreign Patent Documents			
Exam. Initials	Document No.	Date	Country
MW	PCT/US97/08626	05/21/97	PCT
MW	PCT/US97/09069	05/28/97	PCT
MW	PCT/US97/09234	05/30/97	PCT
MW	PCT/US97/09252	05/30/97	PCT
MW	WO9745856	12/04/97	World
MW	WO9745857	12/04/97	World
MW	WO9746056	03/21/00	World
MW	WO9946805	09/16/99	World